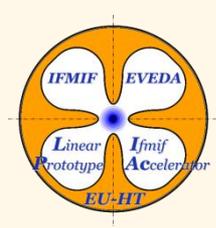


# Development of the LIPAc Ionization Profile Monitor (IPM)

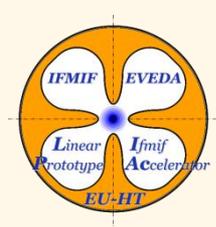
Jan Egberts<sup>1,2,3</sup>, Ph. Abbon<sup>1</sup>, H. Deschamps<sup>1</sup>, F. Jeanneau<sup>1</sup>, J. Marroncle<sup>1</sup>, J-Ph. Mols,  
Th. Papaevangelou<sup>1</sup>

1) CEA Saclay 2) École Doctorale MIPEGE, Université Paris Sud XI 3) Ditanet, FP7, Marie Curie



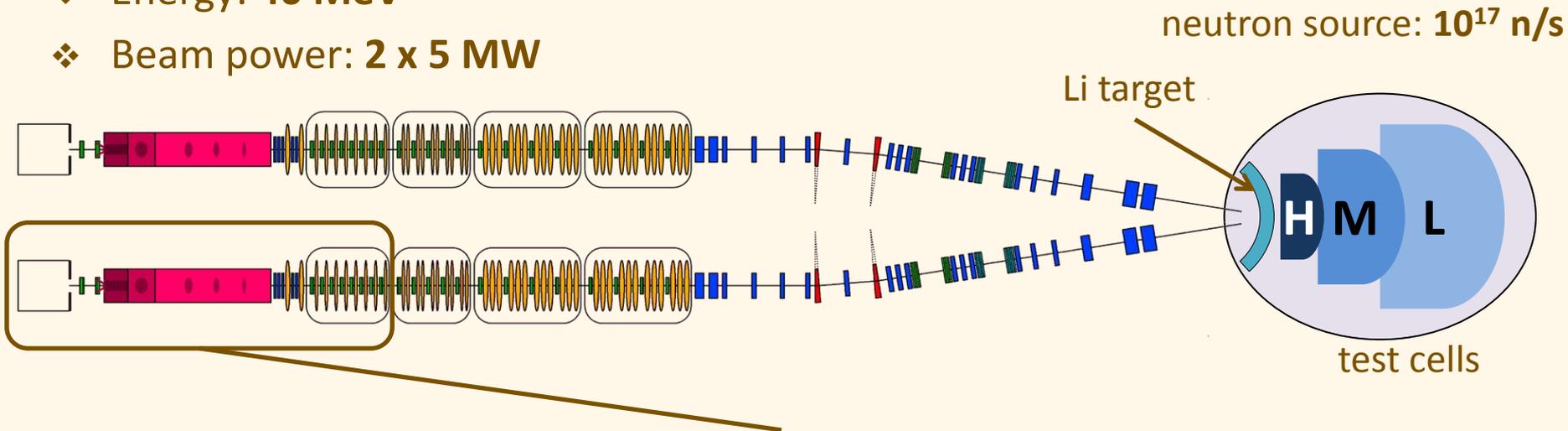
## Outline

- ❖ LIPAc Accelerator (IFMIF - EVEDA)
- ❖ IPM – Characteristics
- ❖ IPM Development
  - ❖ Prototype Test
  - ❖ Final Design
  - ❖ Final IPM Test
- ❖ Conclusion



## IFMIF: International Fusion Material Irradiation Facility

- ❖ Beam current: **2 x 125 mA** cw deuterium
- ❖ Energy: **40 MeV**
- ❖ Beam power: **2 x 5 MW**



## LIPAc: Linear IFMIF Prototype Accelerator

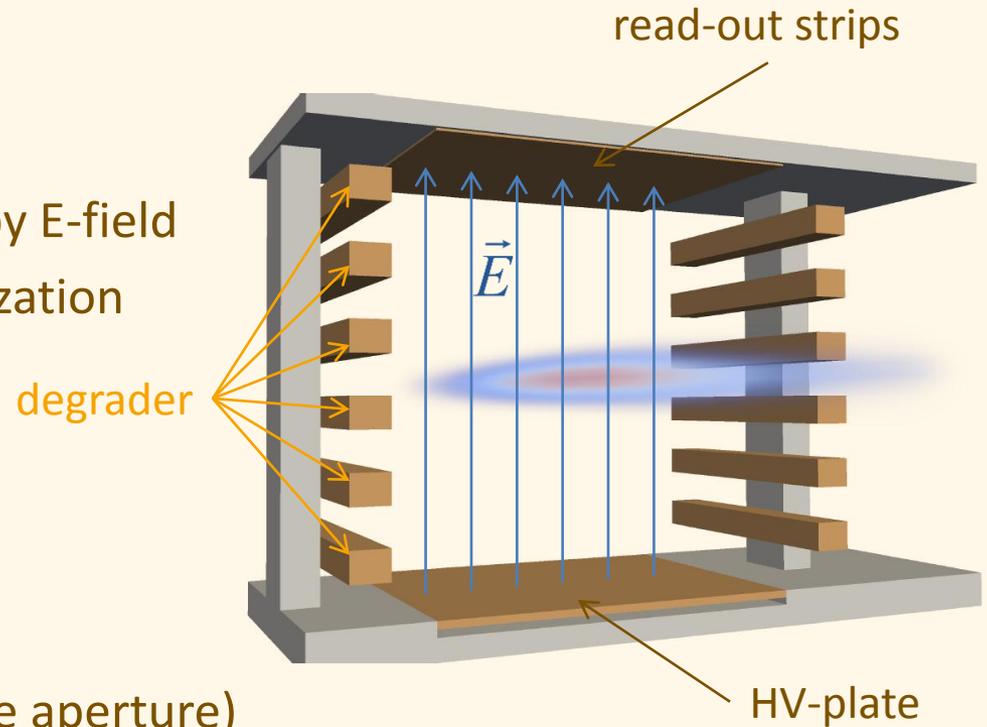
Prototype limited to **1 x 125 mA** cw @ **9 MeV, 1.125 MW**

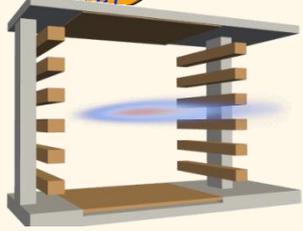
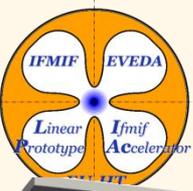
## *Principle of Operation:*

- ❖ Beam ionizes residual gas
- ❖ Electrons / ions are extracted by E-field
- ❖ Beam profile derived from ionization current

## *LIPAc Challenges:*

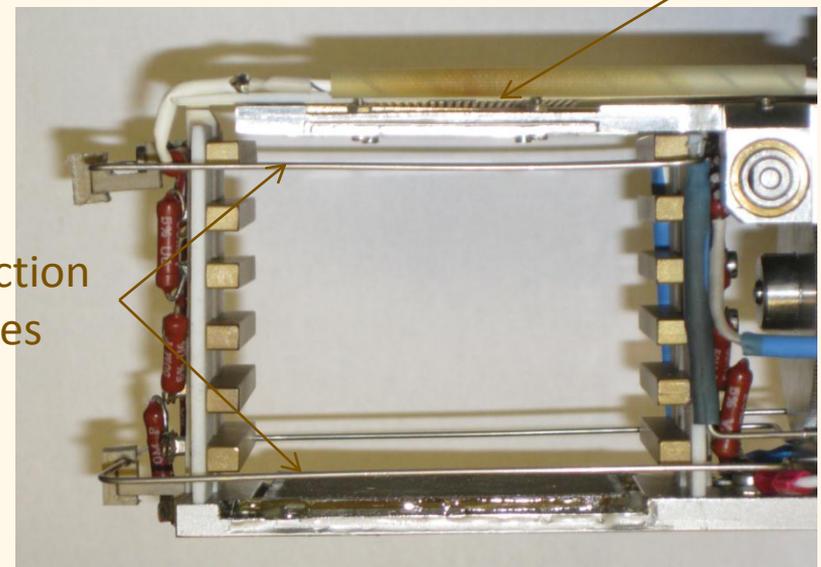
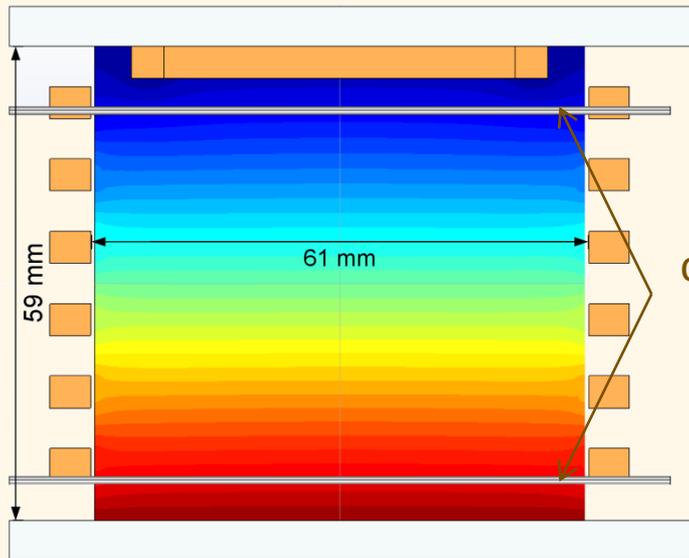
- ❖ Limited space  
⇒ Compact design (wrt. large aperture)
- ❖ High background radiation ( ~7 kSv/h close to the beam dump)
- ❖ Very high space charge effect

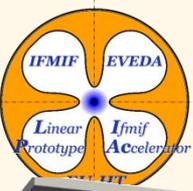




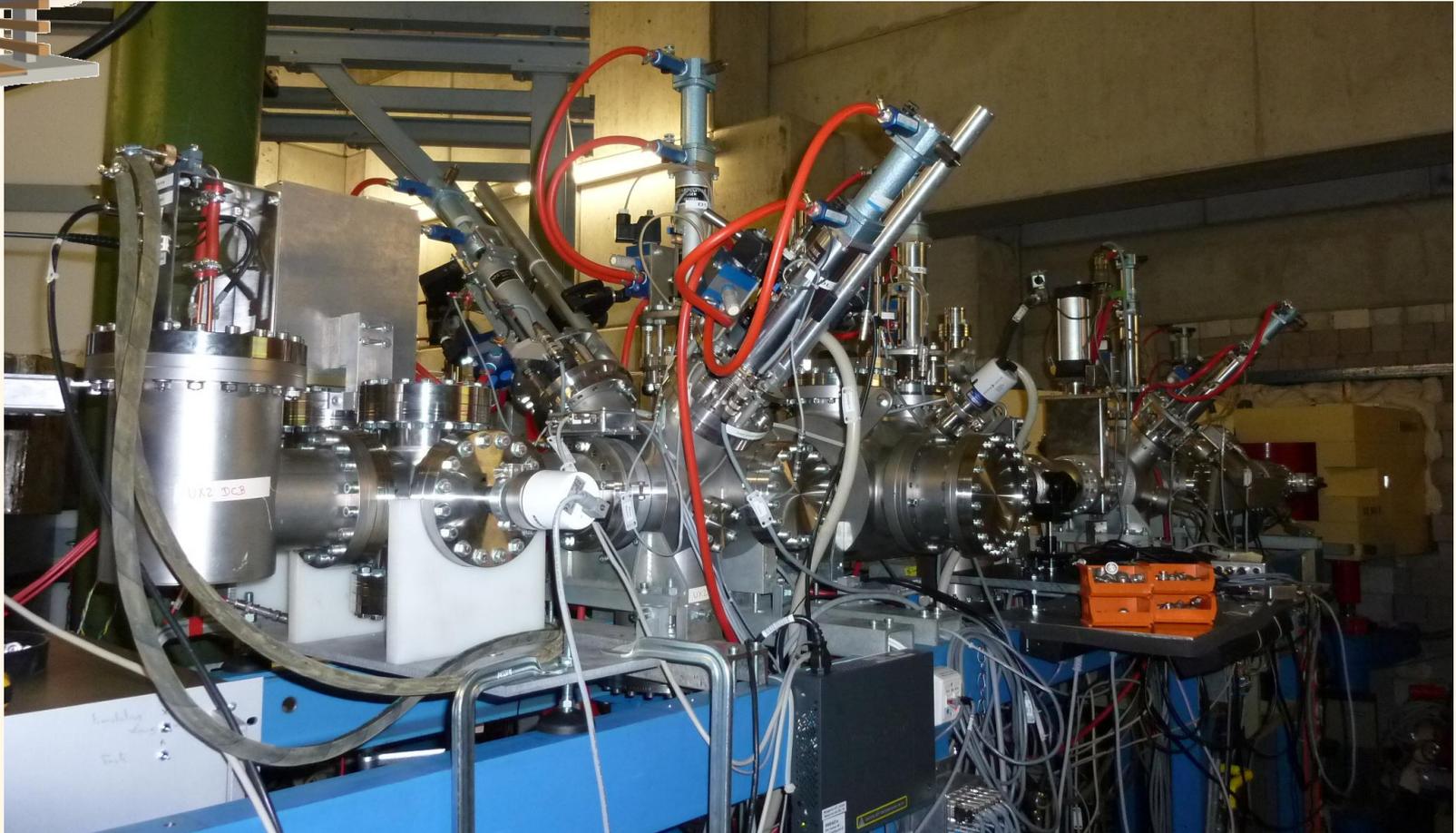
## IPM Prototype Design 2009

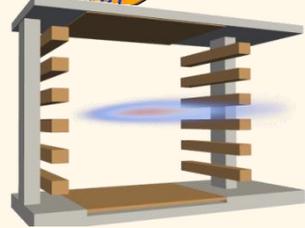
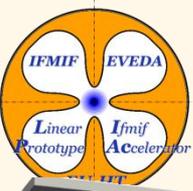
- ❖ Charge collected on 32 strips with 1.25 mm pitch
- ❖ Uniform electric field required to conserve beam profile
- ❖ Prototype designed based on FEM E-field simulations\*
- ❖ Internal dimensions: 61 mm x 59 mm x 40 mm
- ❖ Voltage applied: 5000 V ( $E = 833$  V/cm)





## *IPM test at the UNILAC at GSI 2010*



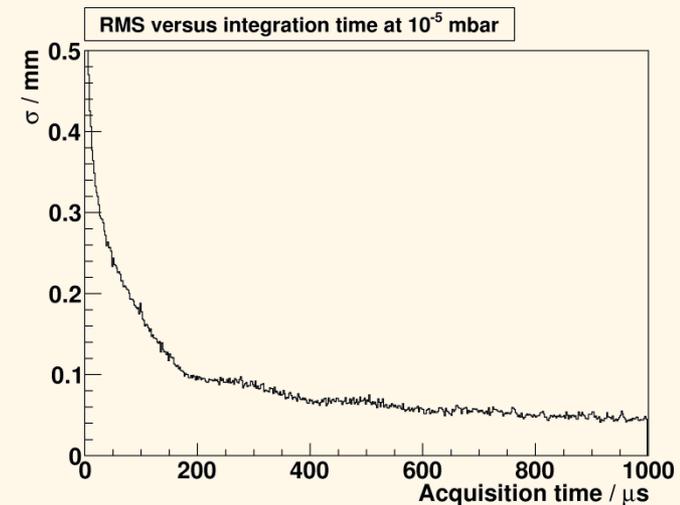
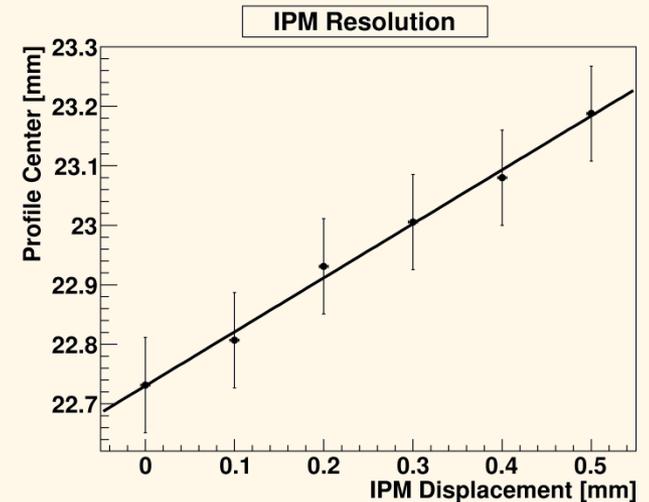


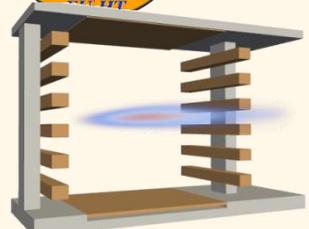
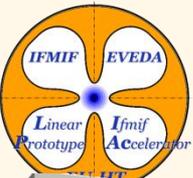
## Position Resolution

- ❖ Move IPM in 100  $\mu\text{m}$  steps perpendicular to the beam
- ❖ Averaged over 60 ms (16.7 Hz)
- ❖ Plot profile center versus IPM position

### IPM resolves well 100 $\mu\text{m}$ profile shifts

- ❖ Fluctuation of beam center versus data acquisition time
- ❖ 120  $\mu\text{A}$   $\text{Xe}^{21+}$ ,  $10^{-5}$  mbar  $\text{N}_2$
- ❖ Plateau of < 100  $\mu\text{m}$  at  $\sim 1\text{kHz}$





## BIF Comparison

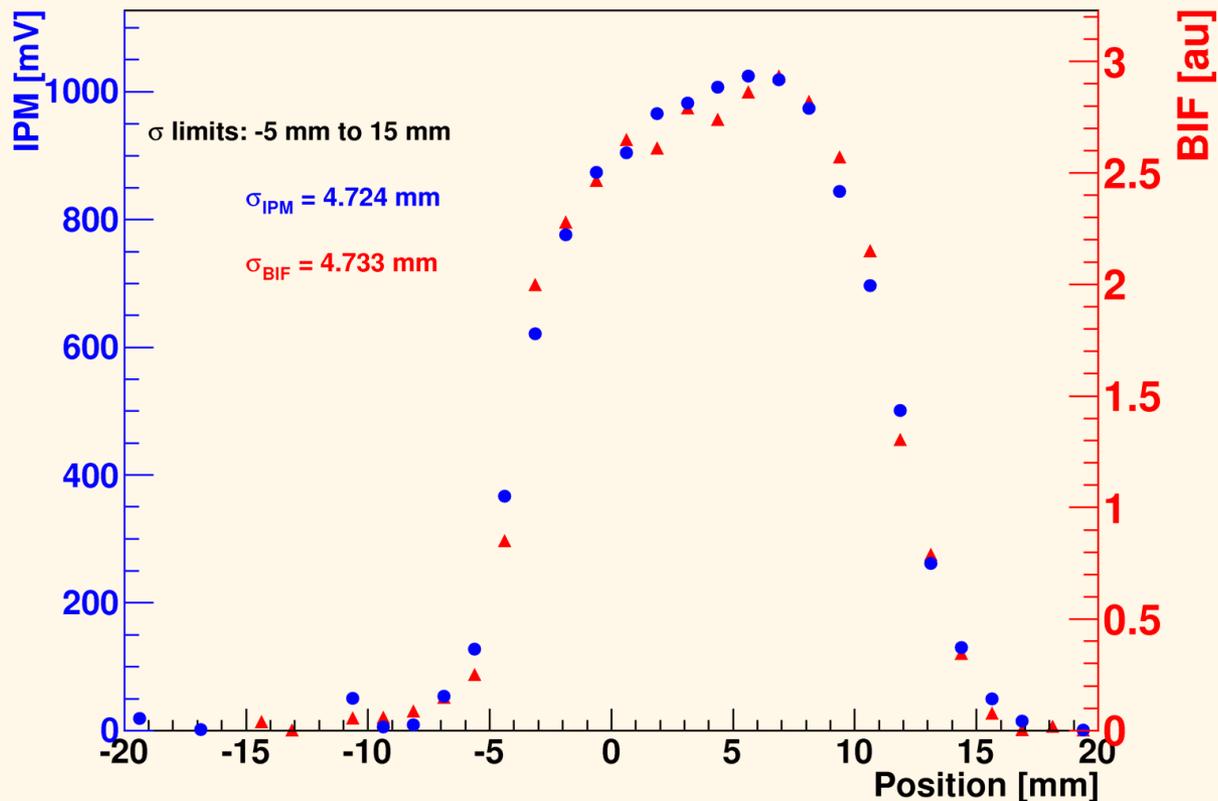
$10^{-5}$  mbar  $N_2$

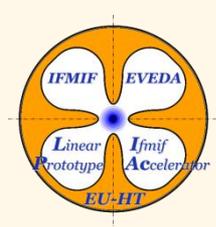
BIF: Beam Induced  
Fluorescence

BIF Monitor based on  
light emitted by atoms  
excited by the beam

BIF profiles acquired  
by *Frank Becker, GSI*

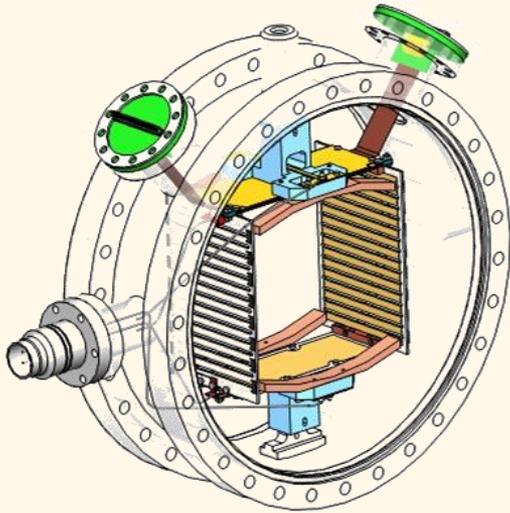
Profile comparison BIF / IPM in  $10^{-5}$  mbar  $N_2$





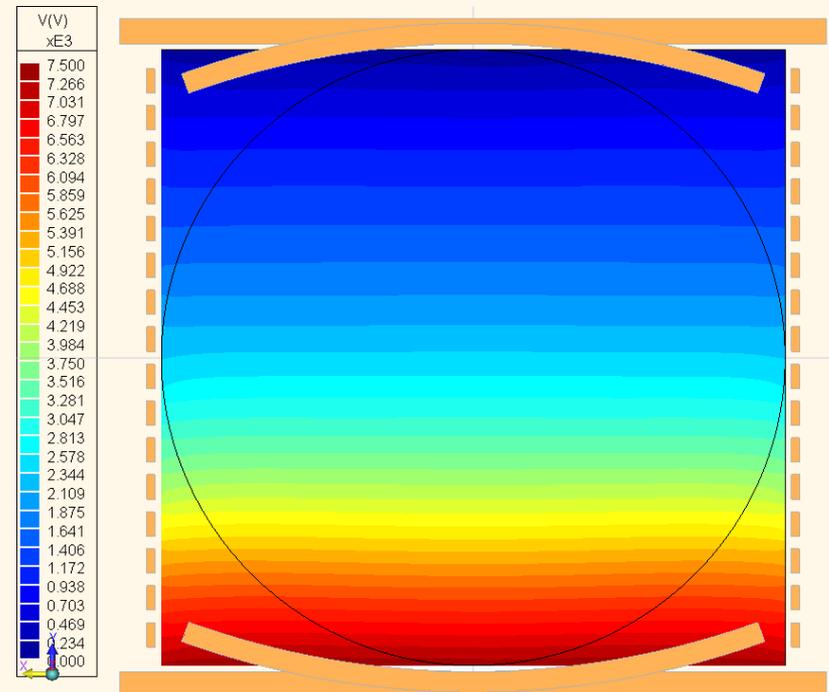
## Final Design Challenges:

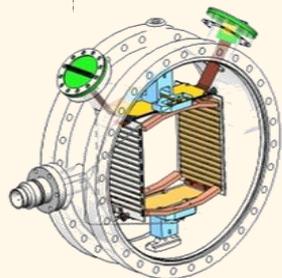
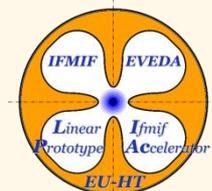
- ❖ Lack of space  $\Rightarrow$  very compact design required
- ❖ High radiation level  $\Rightarrow$  radiation hard components exclusively
- ❖ Space charge effect



## Design results:

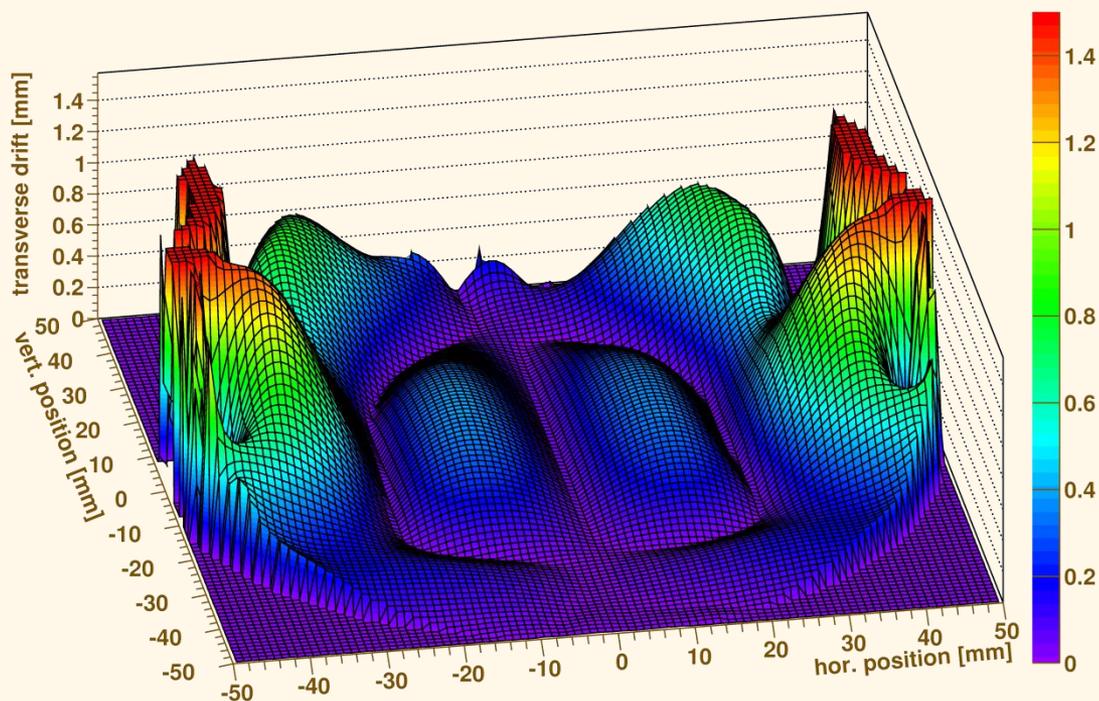
- ❖ Depth of 100 mm with an aperture of 150 mm
- ❖ Active depth: 10 mm
- ❖ E-field uniform within  $\sim 3\%$





## Neglecting Space Charge Effect!

Simulation of the Transverse Ion Drift in the el. Field

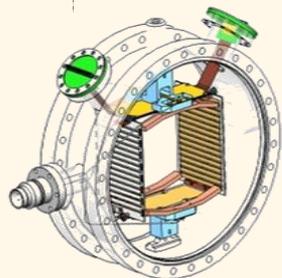
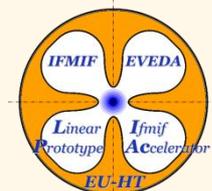


*Particle Tracking:*

Transverse displacement  
during ion drift versus  
starting position

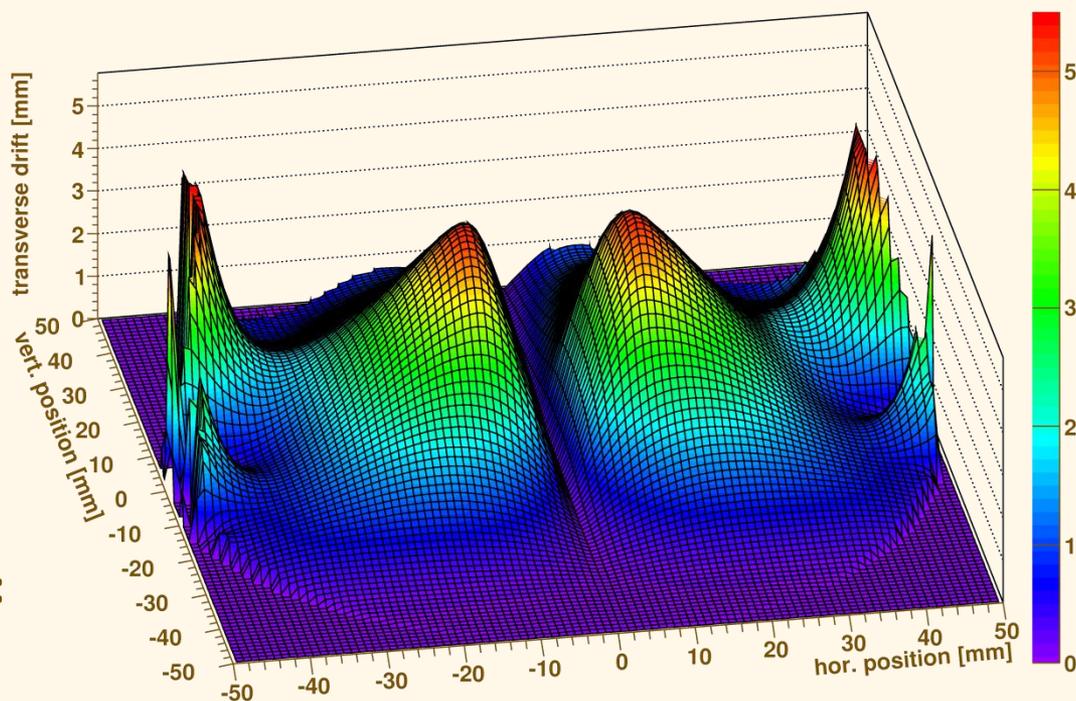
**In beam region:**

**Displacement < 500  $\mu\text{m}$**



## Space Charge for 125 mA Beam

Transverse Ion Drift with a Beam of 125 mA

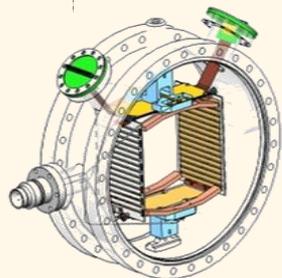
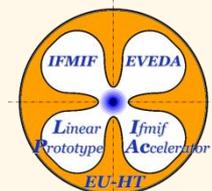


*Particle Tracking:*

Transverse displacement during ion drift versus starting position

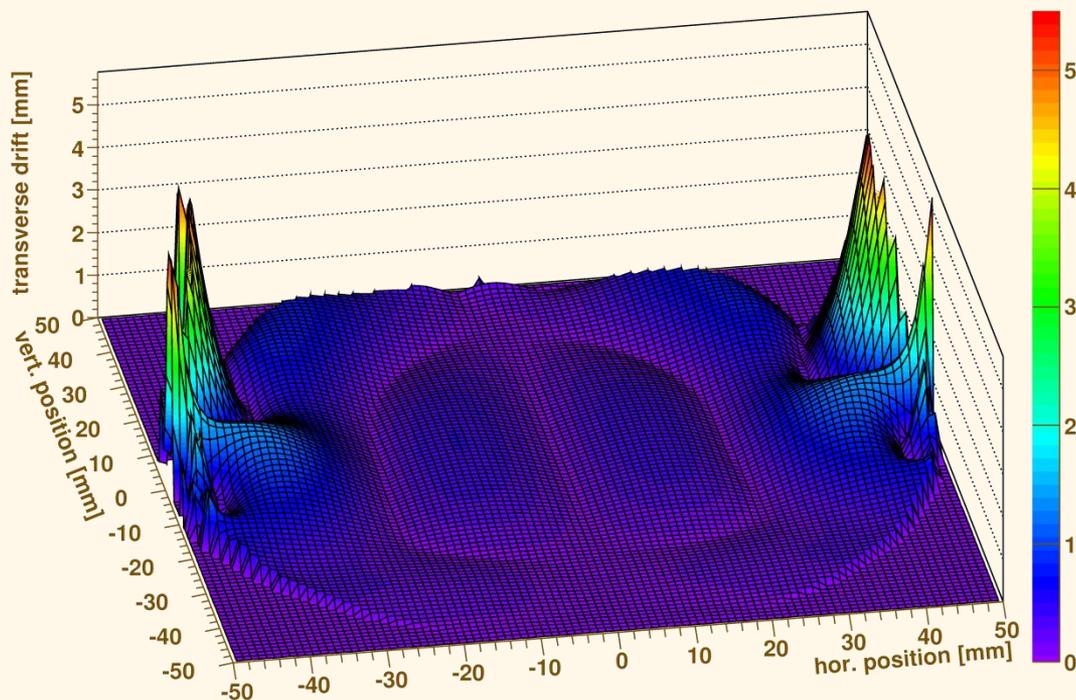
**With space charge of 125 mA:**

**Displacement > 5 mm**



## Neglecting Space Charge Effect!

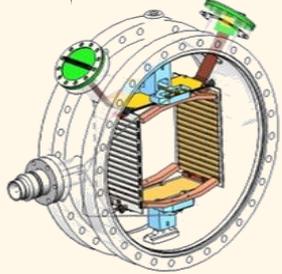
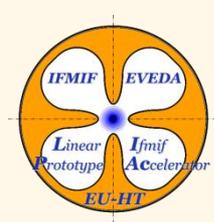
Simulation of the Transverse Ion Drift in the el. Field



*Particle Tracking:*

Transverse displacement during ion drift versus starting position

Tracking w/o space charge in same scale!!!



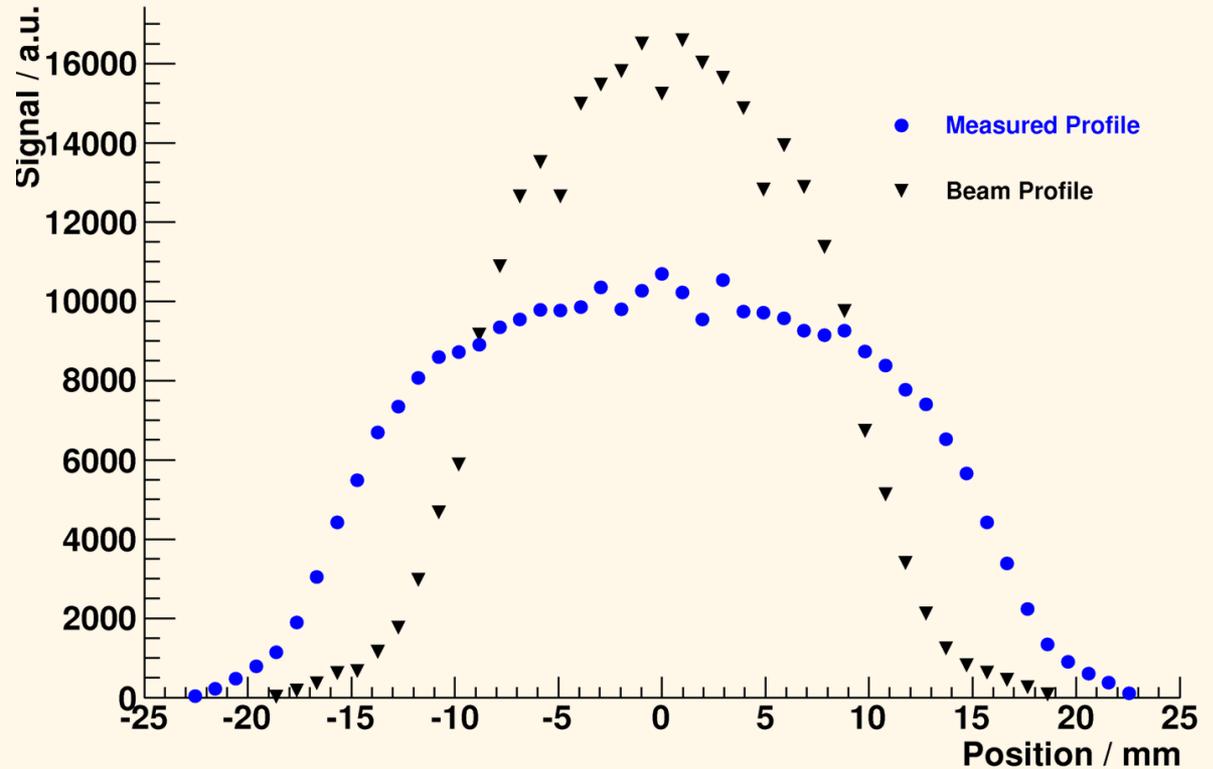
## Simulation of a 9 MeV beam profile measurement @ 125mA:

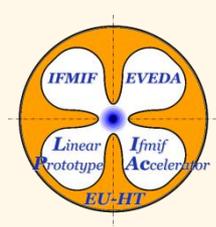
Resulting Profile:

Strong Distortions due to space charge

original beam profile

measured profile  
(simulation)

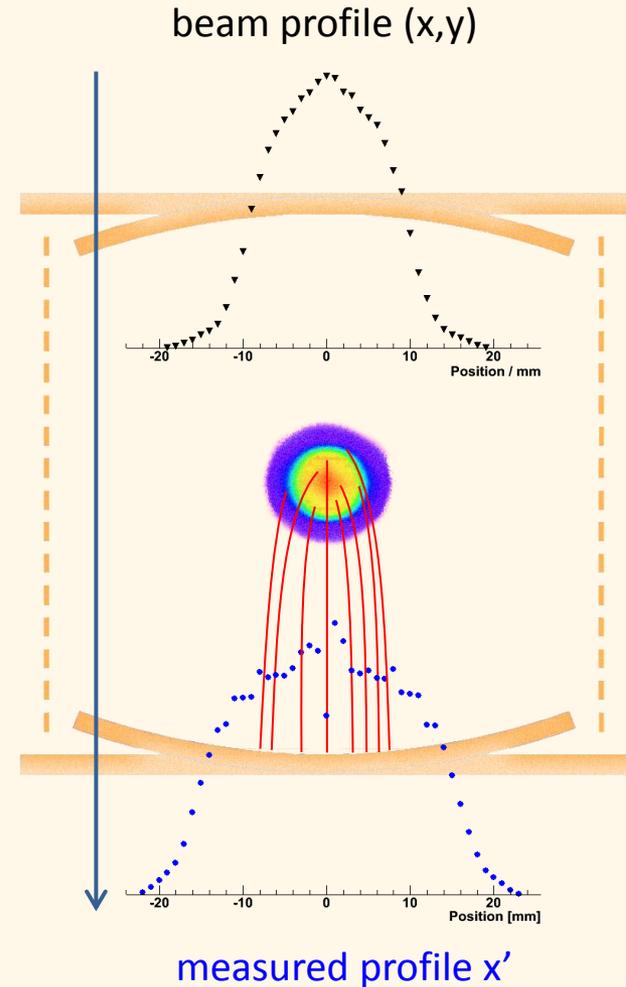




# SC Correction Algorithm

## Idea:

- ❖ Calculate space charge force
- ❖ Determine ion displacement at each position
- ❖ Correct the profile



## Idea:

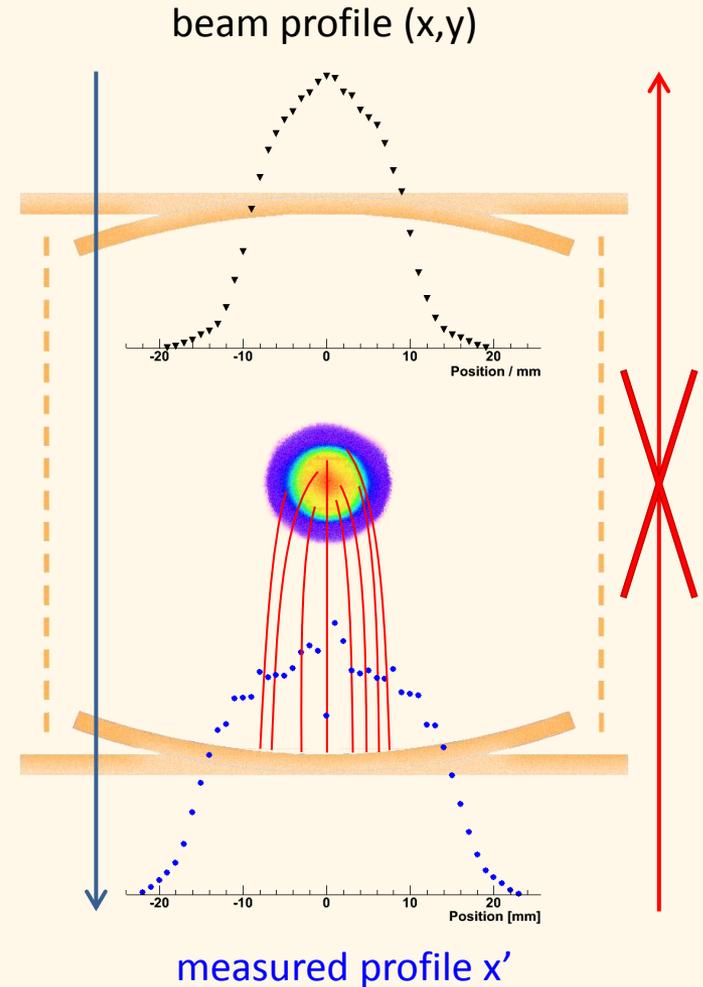
- ❖ Calculate space charge force
- ❖ Determine ion displacement at each position
- ❖ Correct the profile

## Problem:

Beam particle distribution required to calculate space charge force

## Approach:

Assume *beam distribution*....



## Idea:

- ❖ Calculate space charge force
- ❖ Determine ion displacement at each position
- ❖ Correct the profile

## Problem:

Beam particle distribution required to calculate space charge force

## Approach:

Assume *beam distribution*....

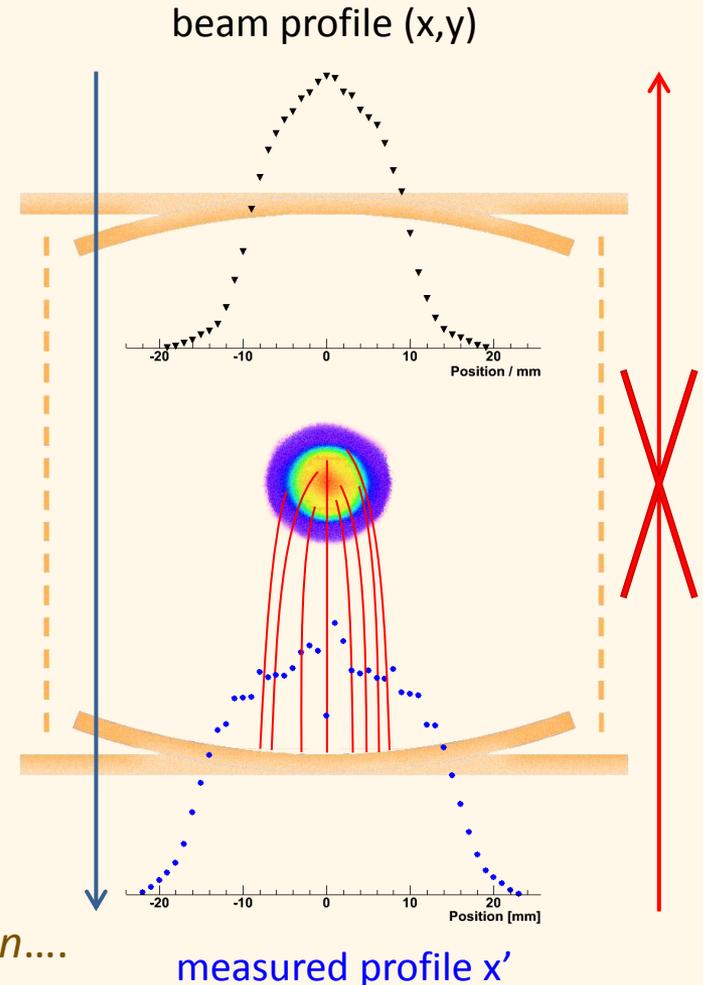
## Problem:

No bijective mapping between  $(x,y)$  and  $x'$

## Approach:

Apply statistics:  $g(x') = \sum p_{x'}(x,y) \cdot (x,y)$

$p_{x'}(x,y)$  is given by *beam distribution*....



## Idea:

- ❖ Calculate space charge force
- ❖ Determine ion displacement at each position
- ❖ Correct the profile

## Problem:

Beam particle distribution required to calculate space charge force

## Approach:

Assume *beam distribution*....

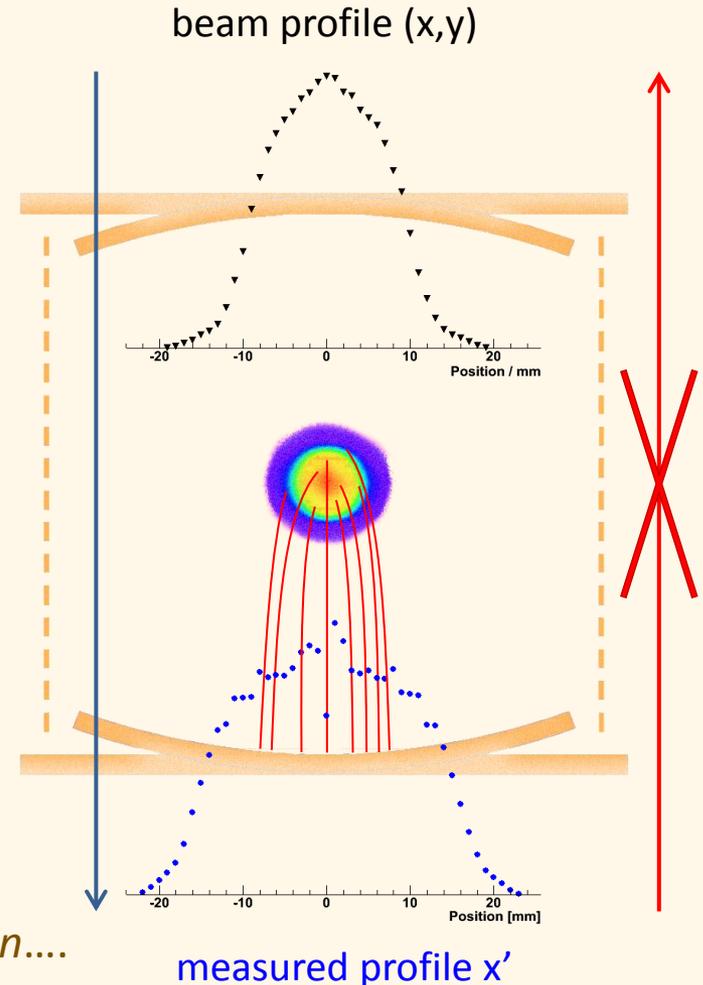
## Problem:

No bijective mapping between  $(x,y)$  and  $x'$

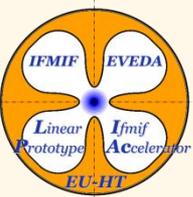
## Approach:

Apply statistics:  $g(x') = \sum p_{x'}(x,y) \cdot (x,y)$

$p_{x'}(x,y)$  is given by *beam distribution*....



⇒ Use test distribution as input!



## What could be a proper test distribution?

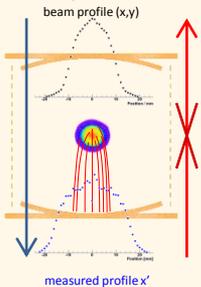
Candidate for test distribution: Generalized Gaussian

$$p_{\alpha,\beta,\mu}(x) = \frac{\beta}{2\alpha\Gamma(1/\beta)} e^{-\left(\frac{|x-\mu|}{\alpha}\right)^\beta}$$

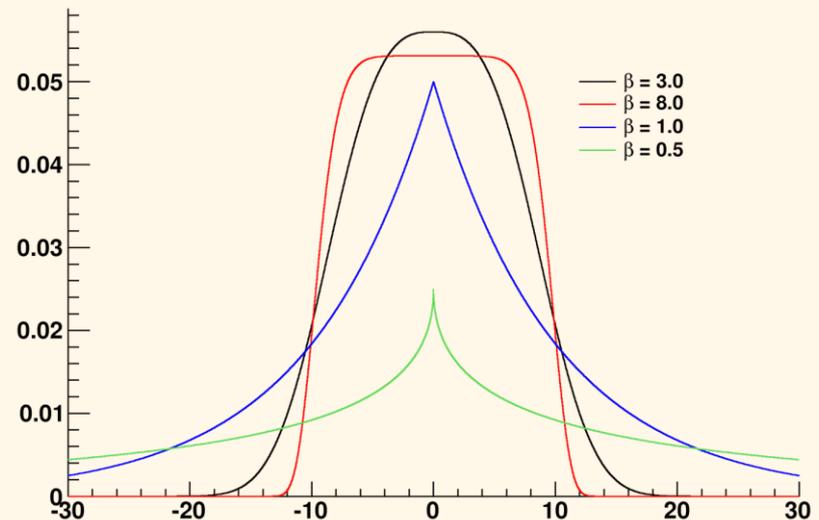
$\mu$  given by profile center

→ two degrees of freedom!

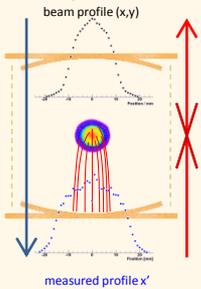
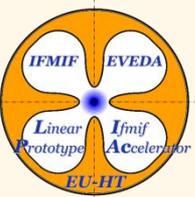
Cover any shape ranging from peaked Gaussian to rectangular distributions!



Generalized Gaussian Distributions



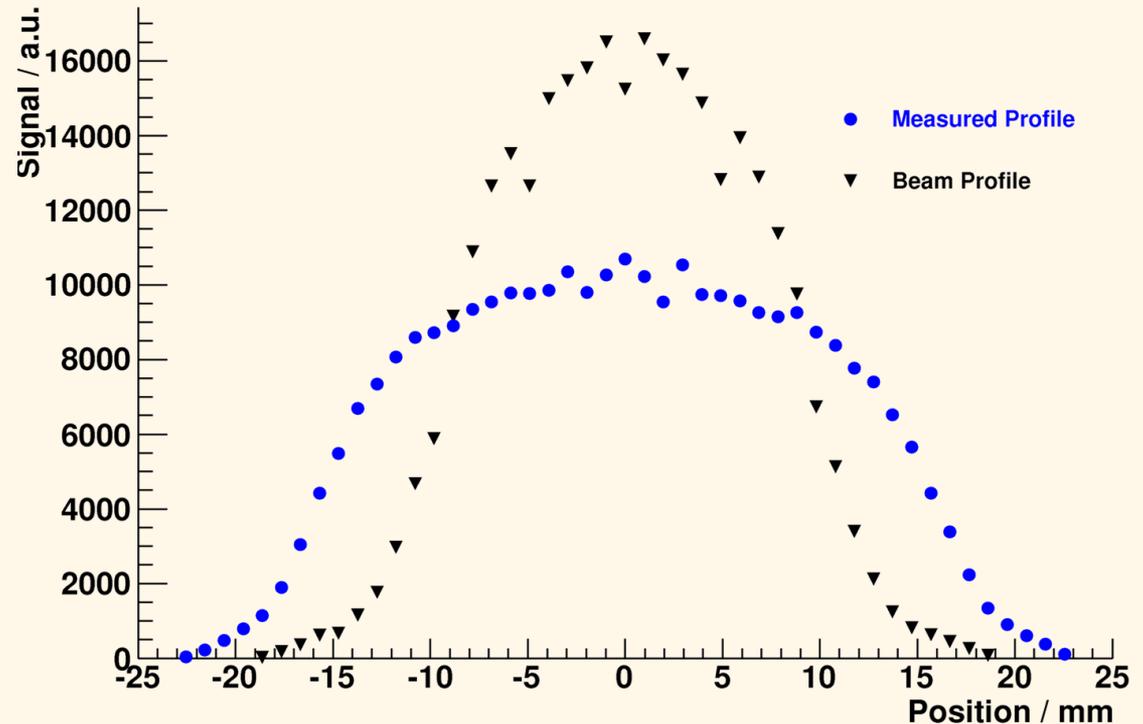
## Simulation of a 9 MeV beam profile measurement @ 125mA:



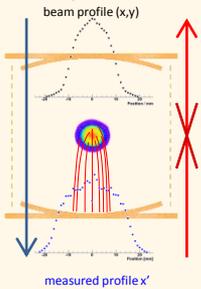
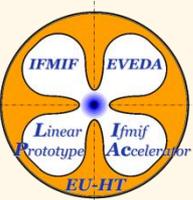
Original beam profile:

RMS: 6.27 mm

Kurtosis: -0.56



## Simulation of a 9 MeV beam profile measurement @ 125mA:



Original beam profile:

RMS: 6.27 mm

Kurtosis: -0.56

Parameters of test distribution:

RMS: 6.30 mm

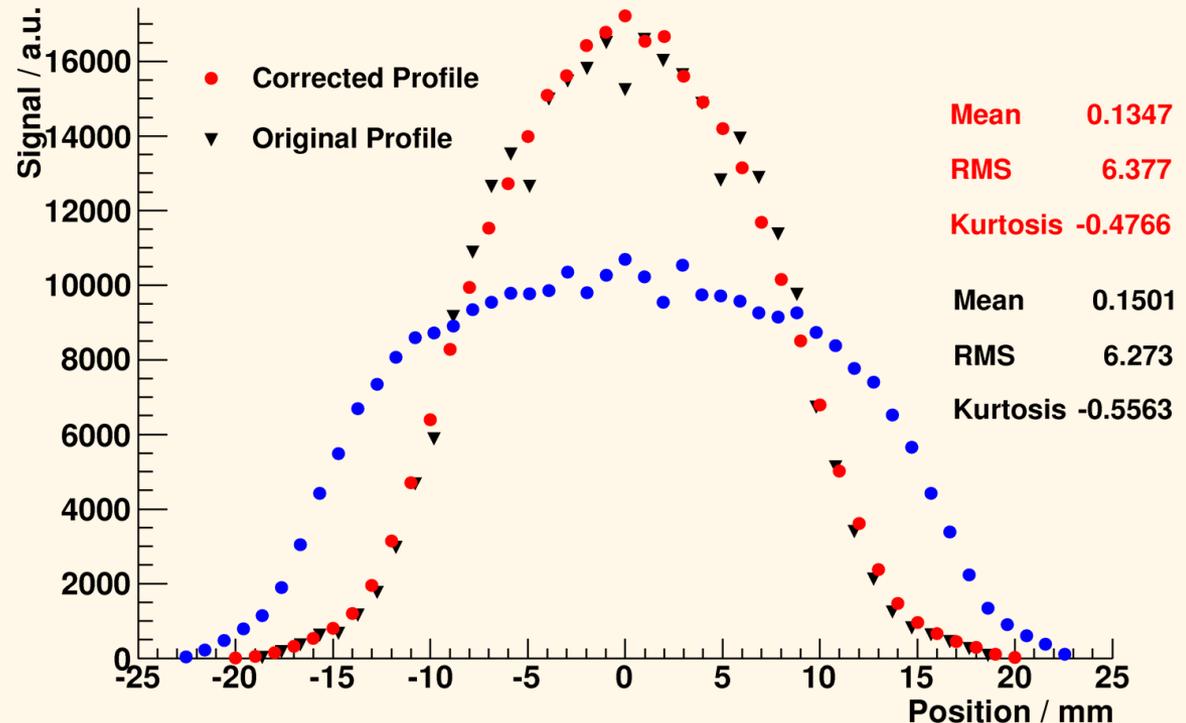
Kurtosis: -0.50

Consistent with:

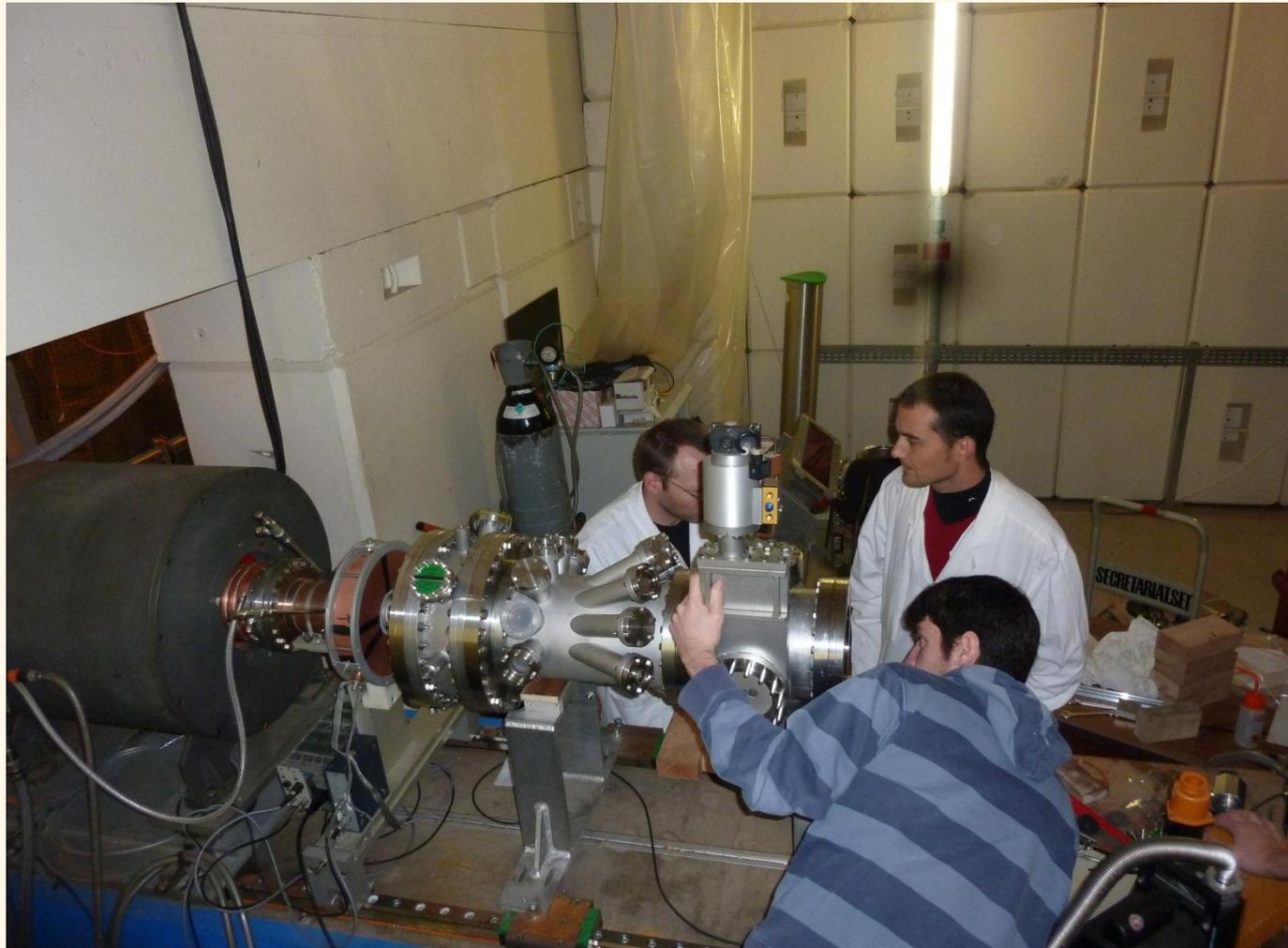
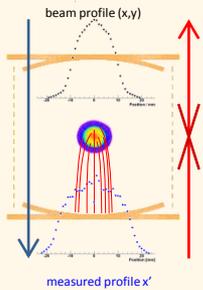
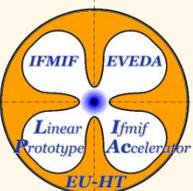
RMS: 6.38 mm

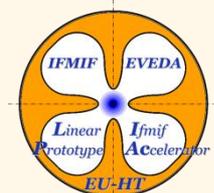
Kurtosis: -0.48

### Self-Consistent Solution

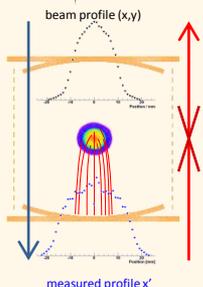


## *IPM test at SILHI source at CEA Saclay 2012*



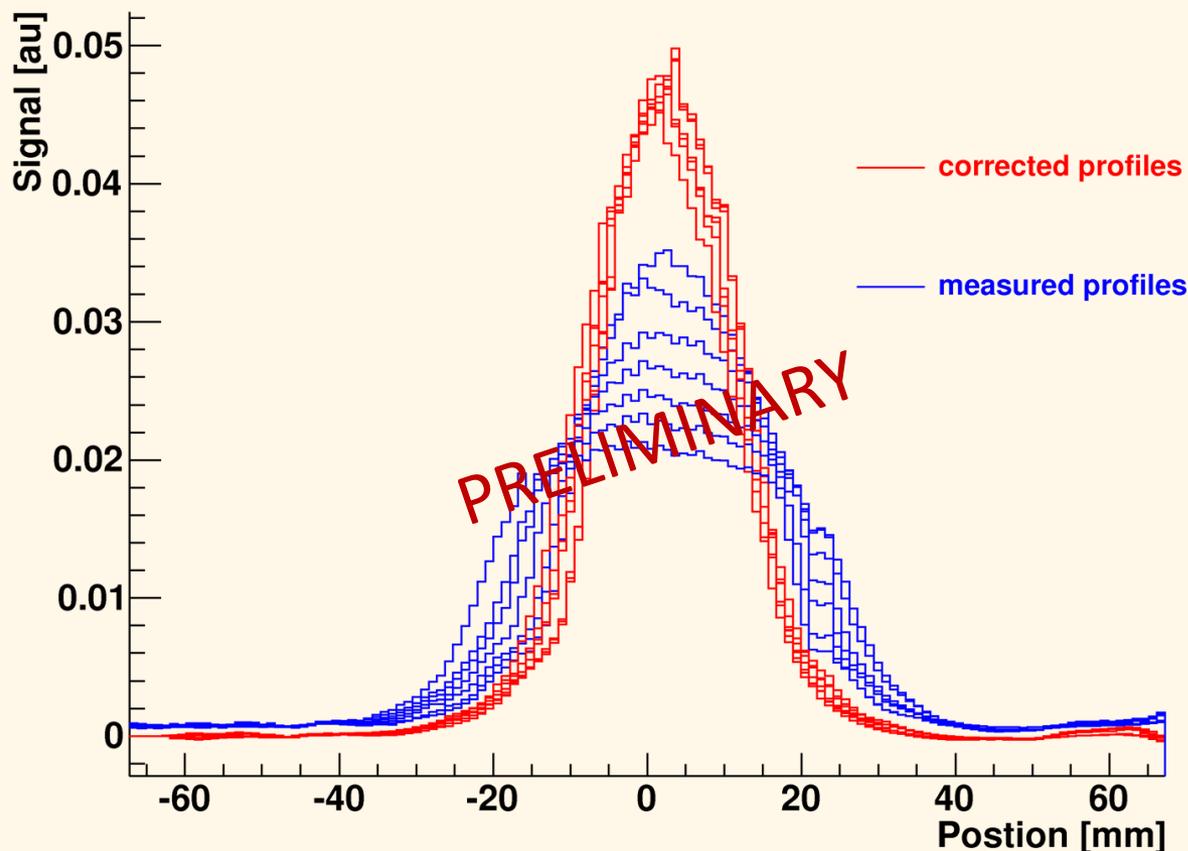


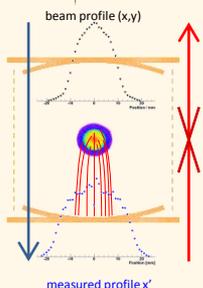
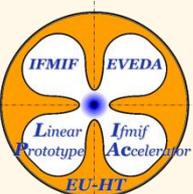
## Test at SILHI source at CEA Saclay



- 6 mA beam @ 90 keV
- Profiles at different IPM voltages (blue)
- SC correction for each voltage
- Corrected profiles (red) should match!

### Profile Corrections



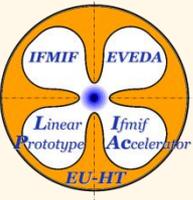


## Advantages:

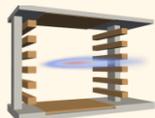
- ❖ Cheap - no additional hardware components required
- ❖ Option to correct for other well-known distortions
- ❖ Generalized Gaussians grant wide range of possible profile shapes
- ❖ Good correction results according to simulations
- ❖ Experimental tests look promising (Analysis not yet terminated!)

## Disadvantages:

- ❖ Still in a very preliminary phase!
- ❖ No correction possible for profiles that cannot be approximated by generalized Gaussians!



## Conclusion



- ❖ IPM prototype extensively tested at GSI

- ❖ Final IPMs designed

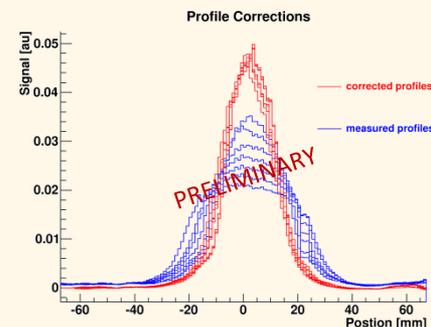
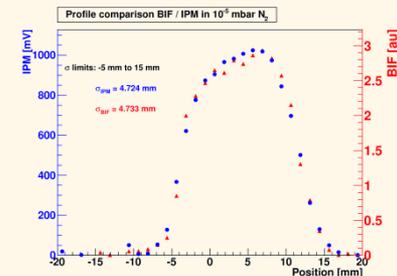
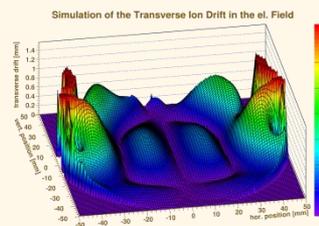
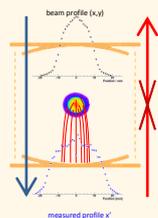
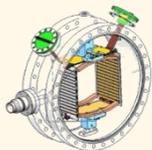
- ❖ Final IPM tested

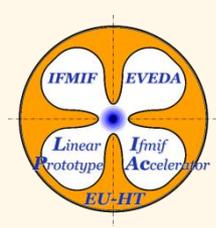
- ❖ Space Effect broadens profile

- ❖ SC correction algorithm

- ❖ Works well in simulation

- ❖ Experimental tests look promising





## *Acknowledgments*

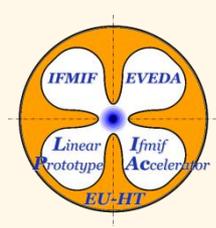
*Sincere Thanks to all the people*

*that have contributed the work!*

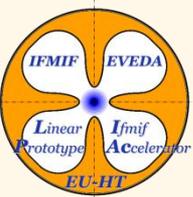
*Particular Thanks* to

the *SILHI group* and

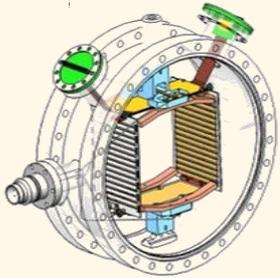
the *Beam Diagnostics group at GSI!*



# Backups



## Example of a *not* self-consistent solution:



Parameters of test distribution:

RMS: 8.72 mm

Kurtosis: -0.81

Not consistent with:

RMS: 7.15 mm

Kurtosis: -0.75

Original beam profile:

RMS: 6.27 mm

Kurtosis: -0.56

Not Self-Consistently Corrected Profile

